

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Tetsuya KUROSAWA et al.)
Serial No.: Not Yet Assigned) Group Art Unit: Not Yet Assigned
Filed: March 25, 2004) Examiner: Not Yet Assigned
For: SEMICONDUCTOR MANUFACTURING)
APPARATUS AND METHOD OF)
MANUFACTURING SEMICONDUCTOR)
DEVICE)

**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§1.56 and 1.97(b), applicants bring to the Examiner's attention the documents listed on attached Form PTO-1449. With exception of the U.S. patents, copies of the listed documents are attached. Applicants respectfully request that the Examiner consider the documents listed on attached Form PTO-1449 and indicate that they were considered by making an appropriate notation on this form. This Information Disclosure Statement is being filed with the above-referenced application.

The following is a concise statement of relevance of the non-English language documents:

1. Japanese Patent Publication No. 2000-091281 - discloses a peeling way of surface protection film (Fig. 4, page 2, lines 60-73).
2. Japanese Patent Publication No. 2000-315697 - discloses a vacuum adsorption way and a peeling way of surface protection film (Fig. 10, page 11, lines 23-44).

3. Japanese Patent Publication No. 2003-179126 - discloses a vacuum adsorption way and a peeling way of surface protection film (Page 17, Figs. 4-7).

An English-language abstract of the listed documents above is also enclosed.

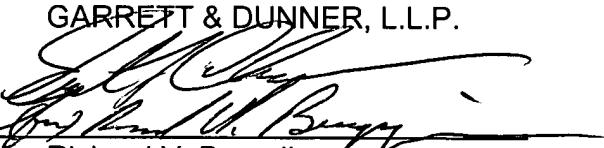
This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and applicants determine that the cited documents do not constitute "prior art" under United States law, applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such documents. Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By:


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Dated: March 25, 2004

Enclosures
RVB/FPD/sci


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INFORMATION DISCLOSURE CITATION

Atty. Docket No.	02887.0271	Serial No.	Not Yet Assigned
Applicants	Tetsuya KUROSAWA et al.		
Filing Date	March 25, 2004	Group:	Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
	4,778,326	10/18/88	ALTHOUSE et al.			
	4,556,362	12/03/85	BAHNCK et al.			
	4,667,944	05/26/87	ALTHOUSE			
	6,220,771 B1	04/24/01	TUNG et al.			
	6,209,532 B1	04/03/01	ARNOLD et al.			

FOREIGN PATENT DOCUMENTS

	Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
	2000-091281	03/31/00	JAPAN			ABSTRACT
	2003-179126	06/27/03	JAPAN			ABSTRACT
	2000-315697	11/14/00	JAPAN			ABSTRACT

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner	Date Considered
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	
Form PTO 1449	Patent and Trademark Office - U.S. Department of Commerce